

Docket No.: 04110/0201116-US0
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshi ISHII et al.

Application No.: 10/813,558

Confirmation No. 4103

Filed: March 29, 2004

Art Unit: 3746

For: VACUUM CONTROL SYSTEM

Examiner: L. J. Weinstein

PRELIMINARY AMENDMENT

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.